

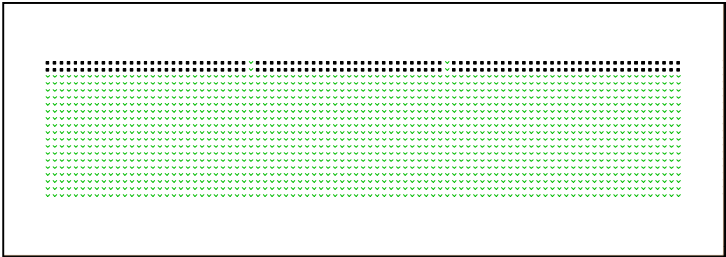
## 3.b Array Instances

- What they are
- How to define them
- How they interact
- How to control their priority



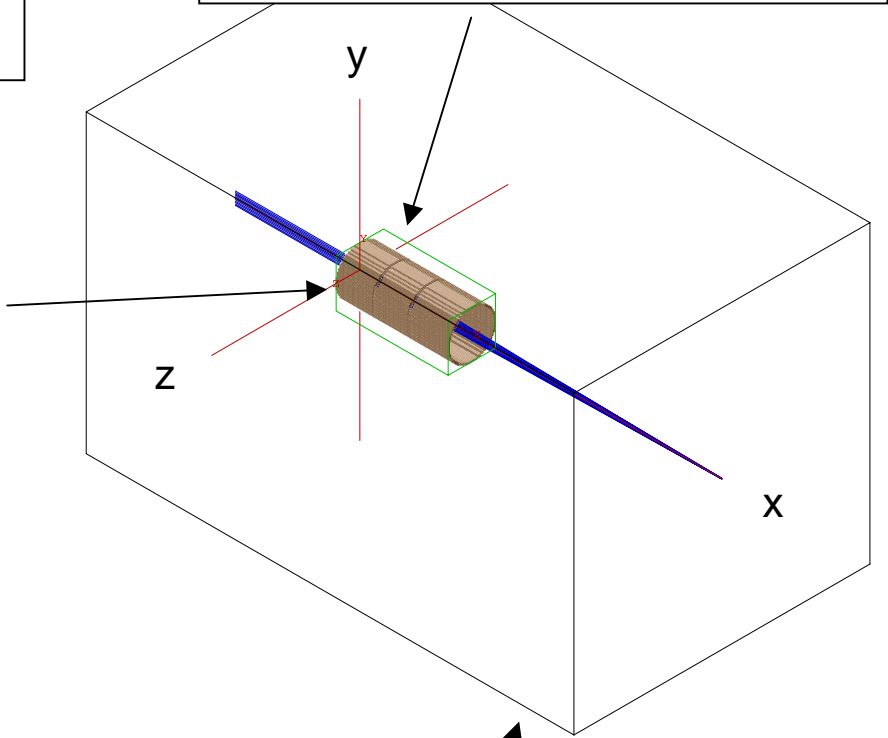
# What is an Array Instance?

A Projected Volume Image of a Potential Array



Potential Array  
2D Cylindrical  
Mirrored in y

Array Instance Volume



Workbench Volume



# Why are Instances Useful?

- Links PAs into the virtual workbench world
- Electrostatic and magnetic fields in same volume
- Allows higher density arrays in certain regions (e.g. sources).
- Supports simulation of beam lines with separated optics stages.



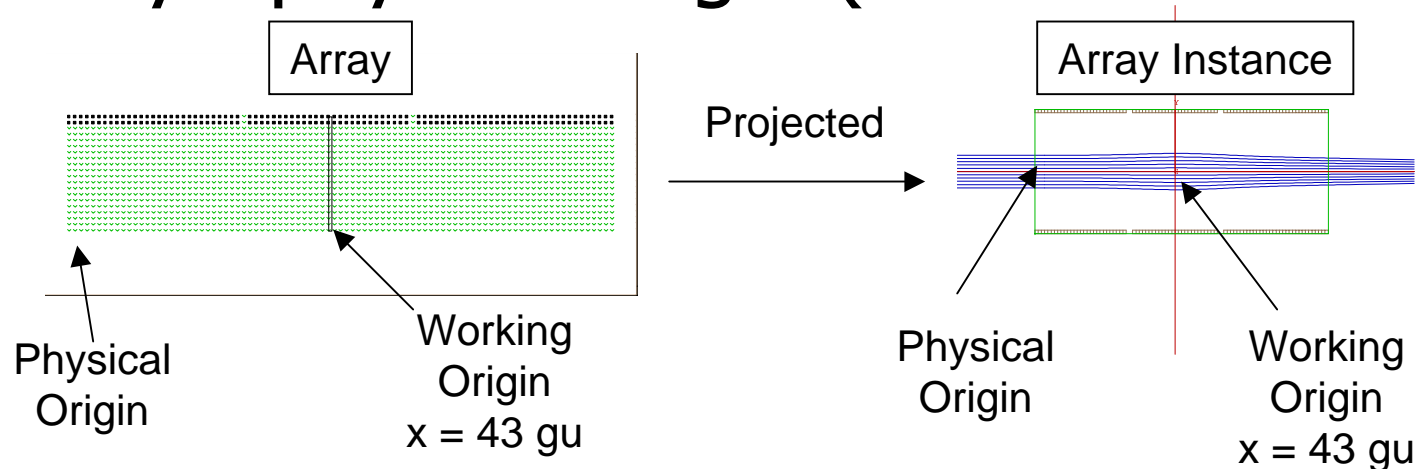
# How Instances are Defined

- Working Origin
- Offset of Working Origin from WB Origin
- Scaling in mm/gu
- Orientation Angles from Working Origin in
  - Azimuth
  - Elevation
  - Rotation

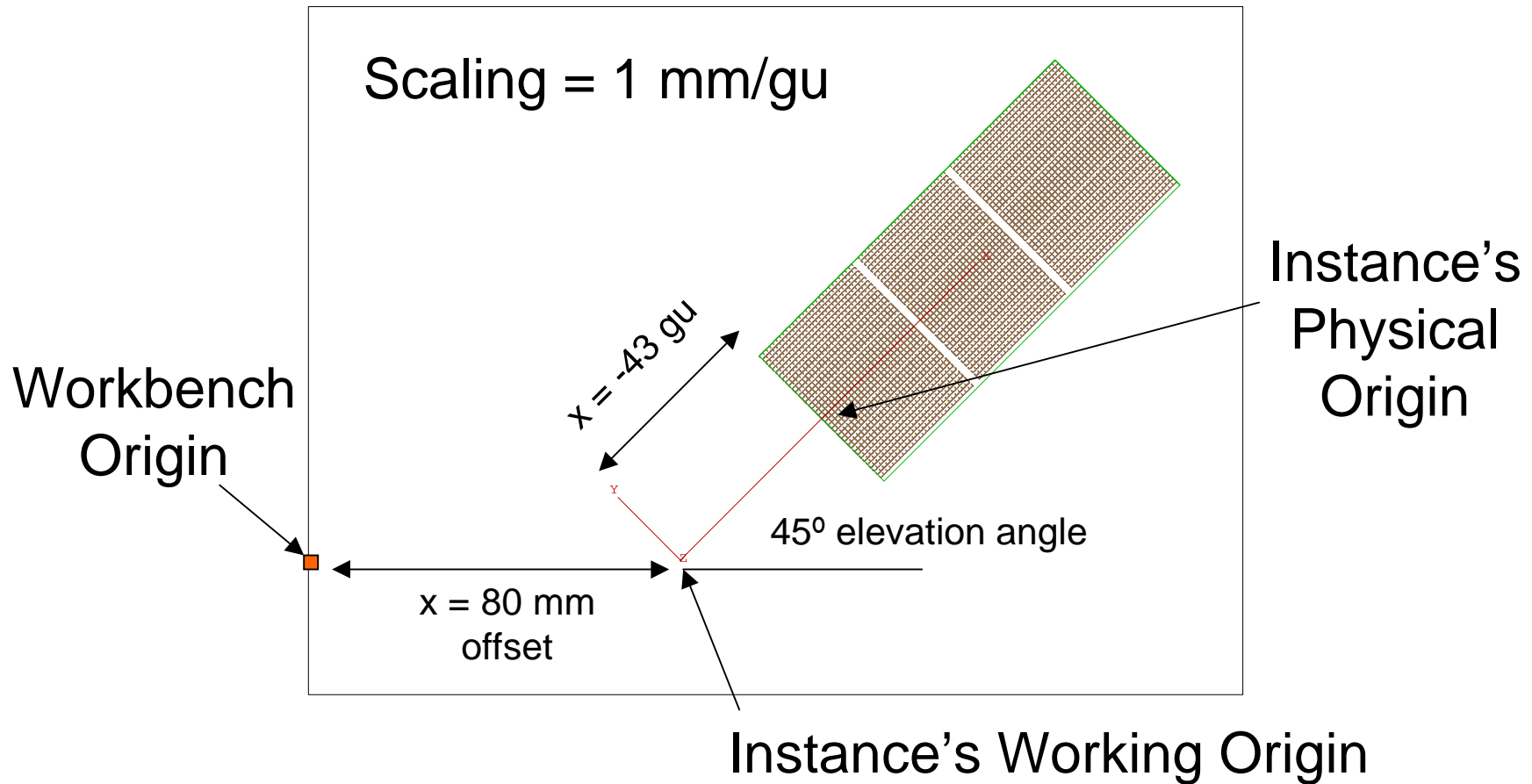


# Working Origin

- Working Origin is the reference point for all positioning, scaling and orientations
- It is defined in terms of an offset from the array's physical origin (0 offset is default)



# Instance Positioning, Scaling, and Orientation

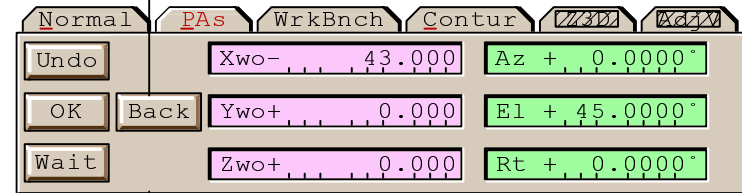
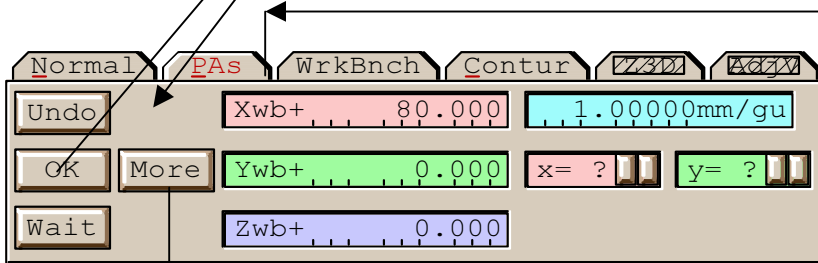
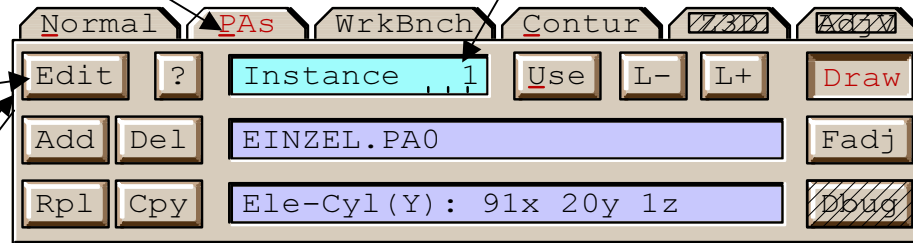


# Editing an Instance

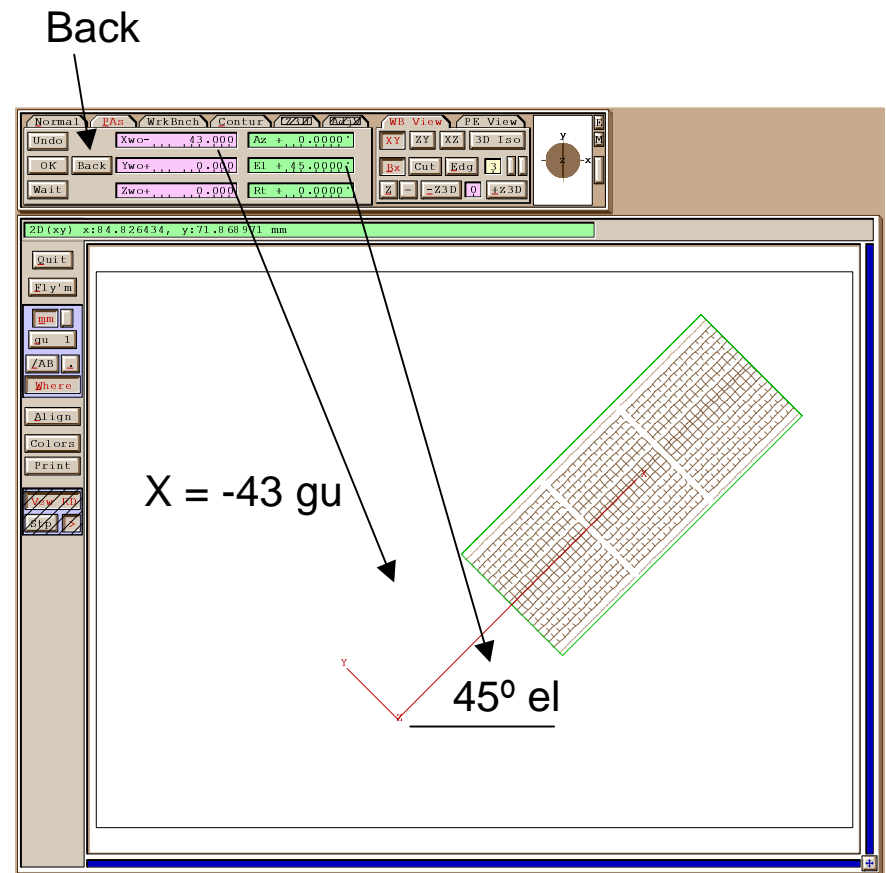
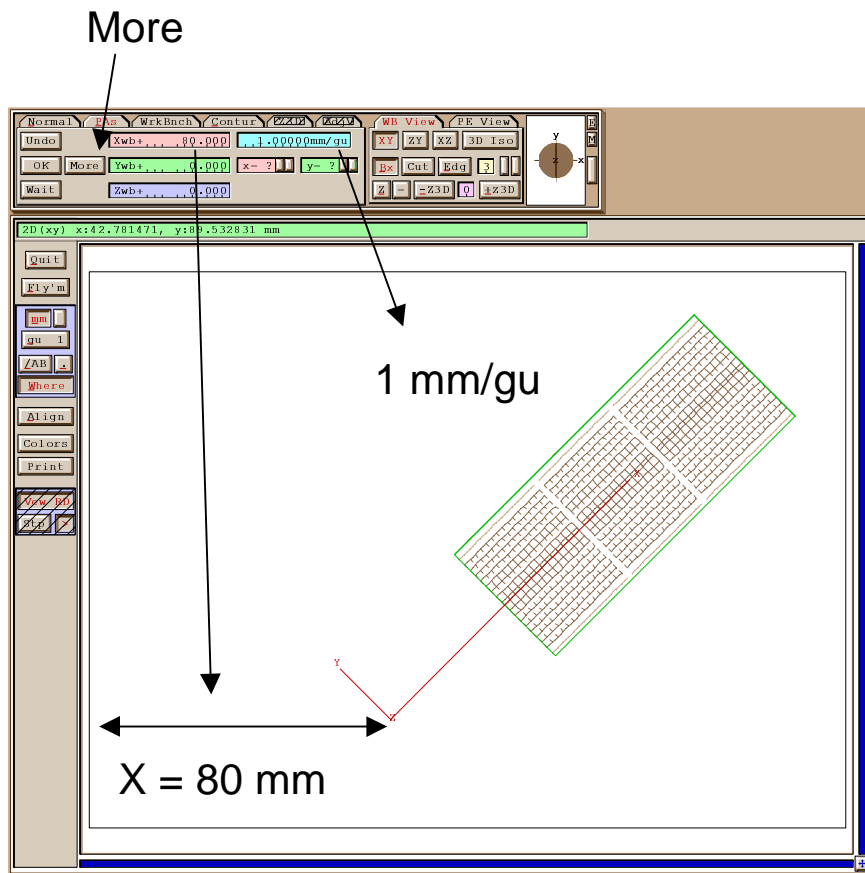
1. Select PAs Tab

2. Select Instance's Number

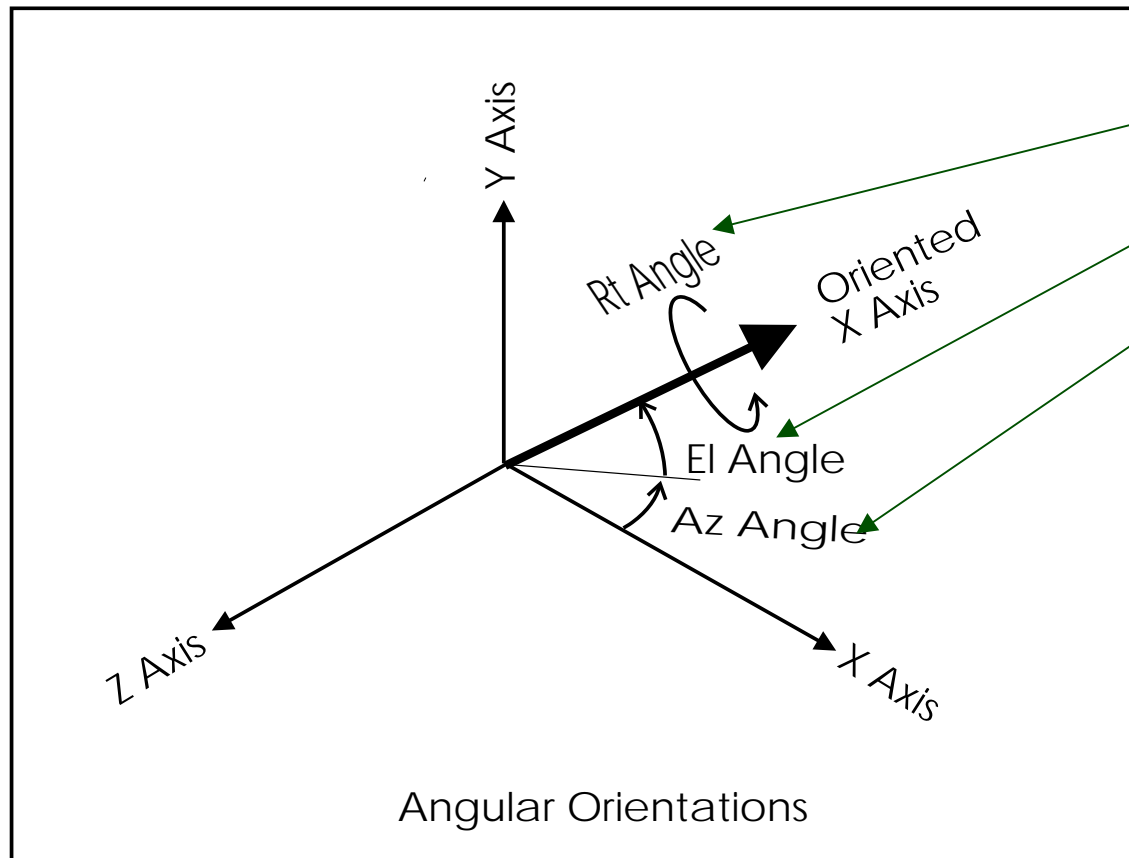
3. Select Edit



# SIMION Instance Editing



# Order of Orientations and displacements



1. Rt angle
2. El angle
3. Az angle
4. Working Origin offset from array physical origin
5. Working Origin offset from workbench origin

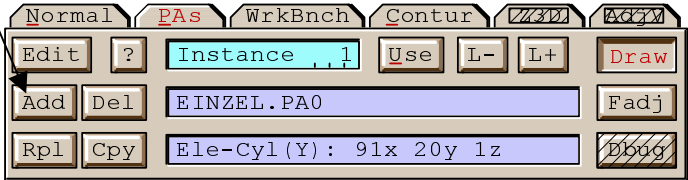


# Adding an Instance

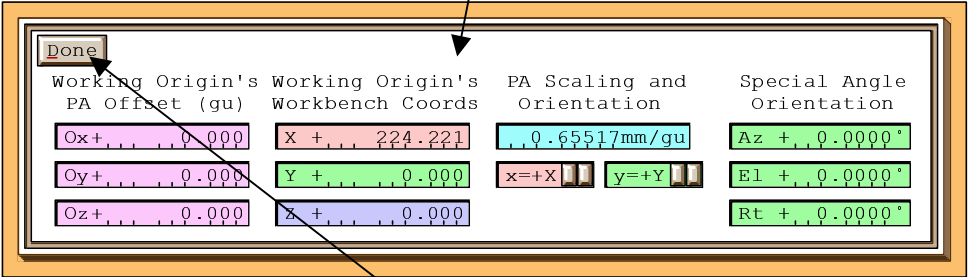


1. Mark Volume

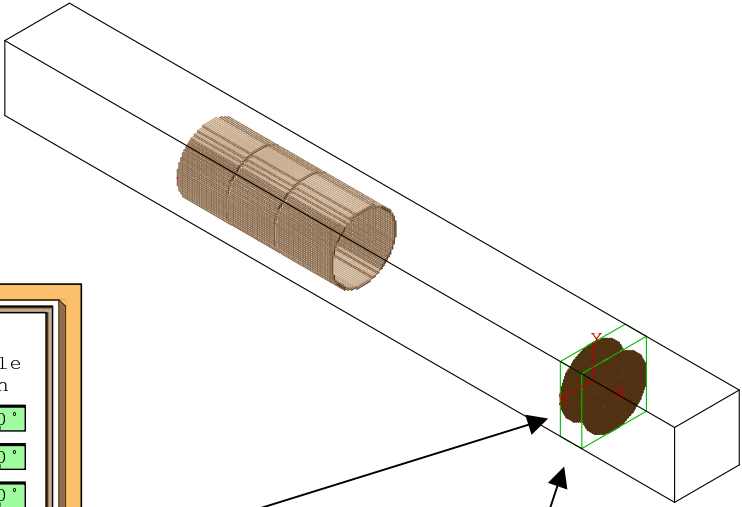
2. Click Add



3. Edit Instance Definition



4. Click Done



New Array Instance



# Instance Rules

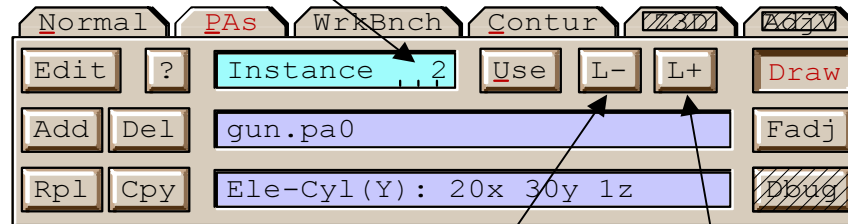
- Instance Fields are Separate
  - Each instance is an isolated island.
  - Only linear acceleration fields are assumed when ions fly between instances of differing electrostatic potentials (won't work with RF).
  - Instance Fields that overlap do NOT merge.
  - Overlapping instance volumes defer to the highest priority instance.



# Instance Priority

- The instance with the highest number has the highest priority

Instance Number (and Priority)



Lower Instance's Number

Raise Instance's Number



# Other Instance Options

